Electronic Supplementary Information (ESI)

Improving Low-Energy Boron/Nitrogen Ion Implantation in Graphene by Ion Bombardment at Oblique Angles

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Figure S1. Side-view MD trajectories that complement the snapshots shown in Figure 5(d-f). These side-view MD trajectories can be directly compared with the mechanism schematics shown in Figure 5(a-c).

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Figure S2. Side-view MD trajectories that complement the snapshots shown in Figure 8(e-h). These side-view MD trajectories can be directly compared with the mechanism schematics shown in Figure 8(a-d).